



PATENT APPLICATION
Q62494

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re application of

Ryo KUBOTO, *et al.*

Appln. No.: 09/817,233

Group Art Unit: 2823

Confirmation No.: 8072

Examiner: Hsien Ming LEE

Filed: March 27, 2001

For: MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE HAVING DRAM CAPACITORS

AMENDMENT UNDER 37 C.F.R. §1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 29, 2004, please amend the above-identified application as follows on the accompanying pages.

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